

ITS3: A truly cylindrical inner tracker for ALICE

Jory Sonneveld on behalf of the ALICE collaboration

jory.sonneveld@nikhef.nl



UNIVERSITY
OF AMSTERDAM

Inner Tracker: 3 layers, 22-42 mm from IP, 0.36% X_0

Outer Tracker: 4 layers, 194-395 mm from IP, 1.1% X_0

**pixels of
27 μm x 29 μm**

**ALICE inner
tracking system 2
(ITS2):**

**First monolithic
active pixel sensors
at LHC**

**12.5 GPix 10 m² active area:
largest pixel detector ever built!**



ALICE

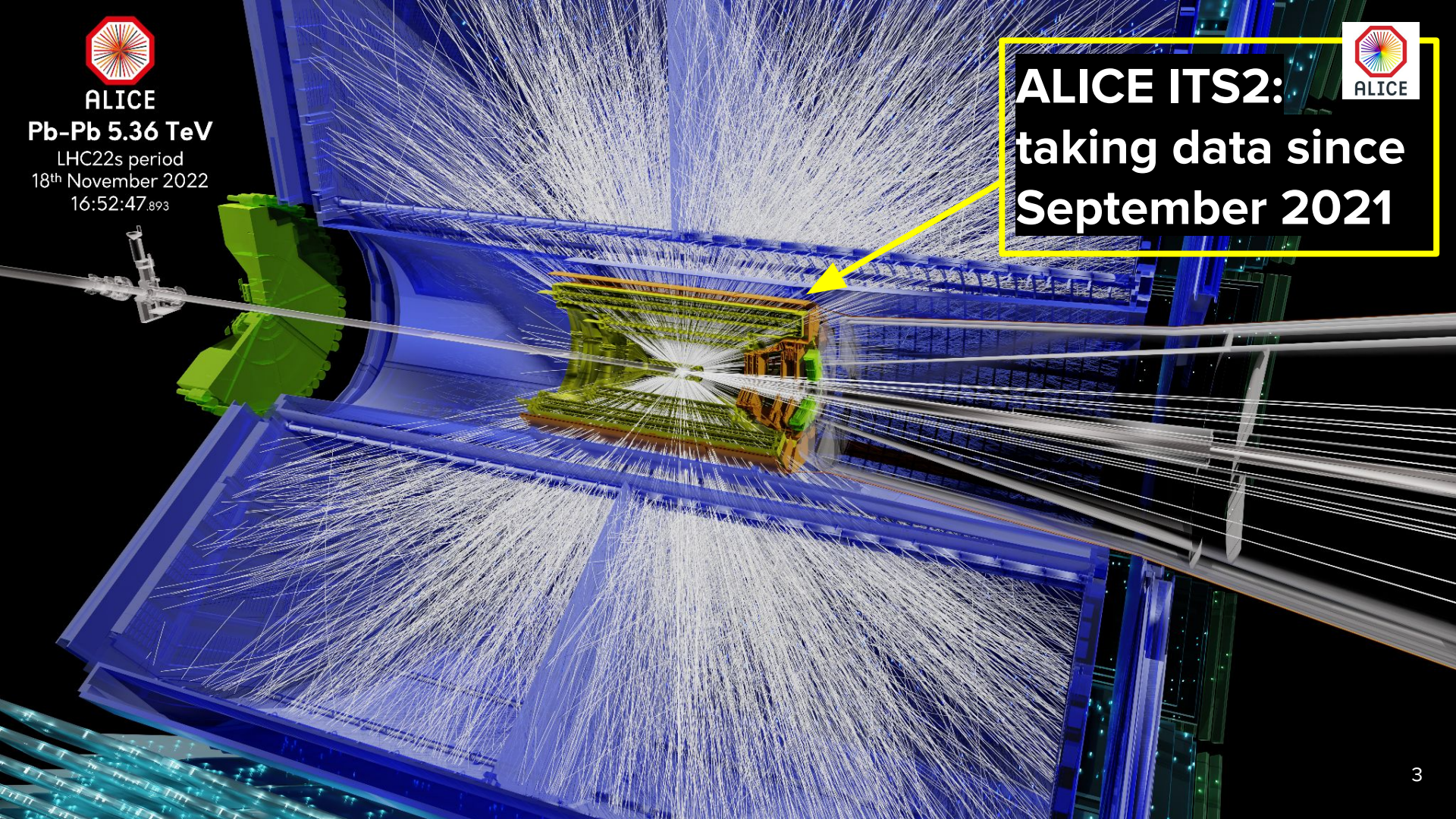
Pb-Pb 5.36 TeV

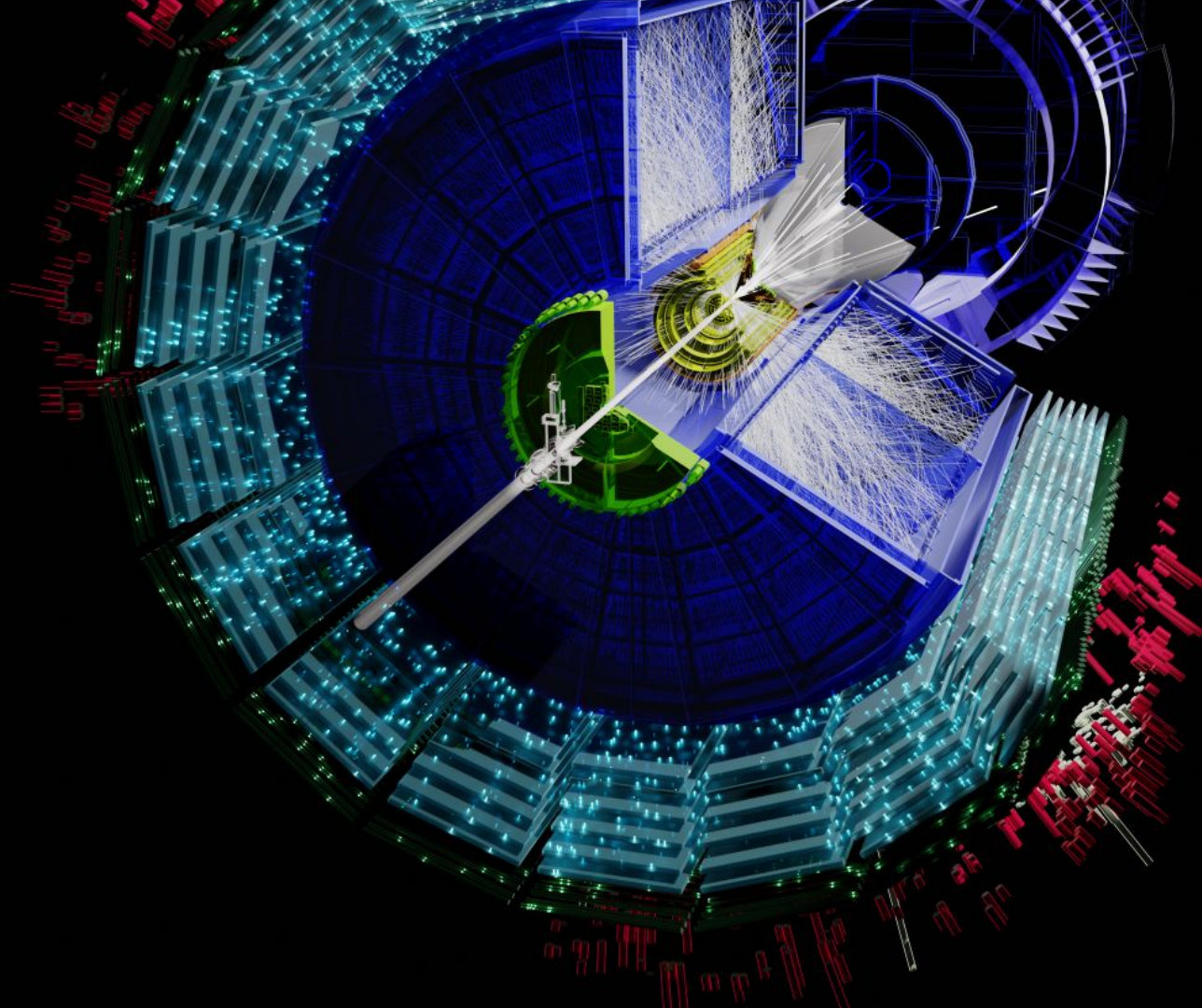
LHC22s period
18th November 2022
16:52:47.893



ALICE

**ALICE ITS2:
taking data since
September 2021**





ALICE

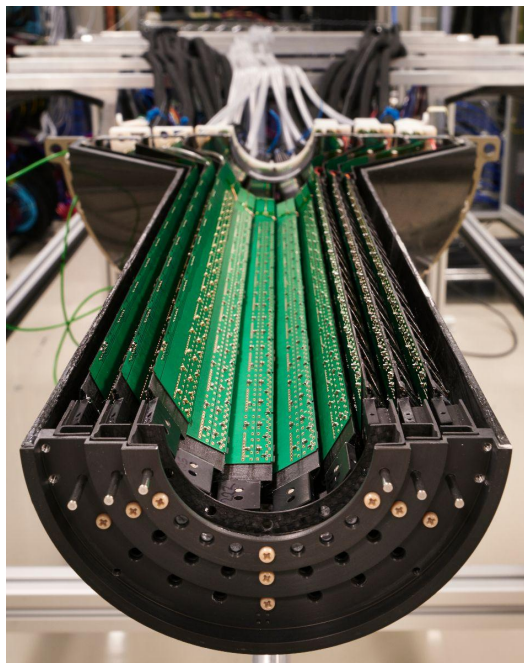
Pb-Pb 5.36 TeV

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Future upgrade of the ALICE inner tracking system

0.36% X_0 per layer



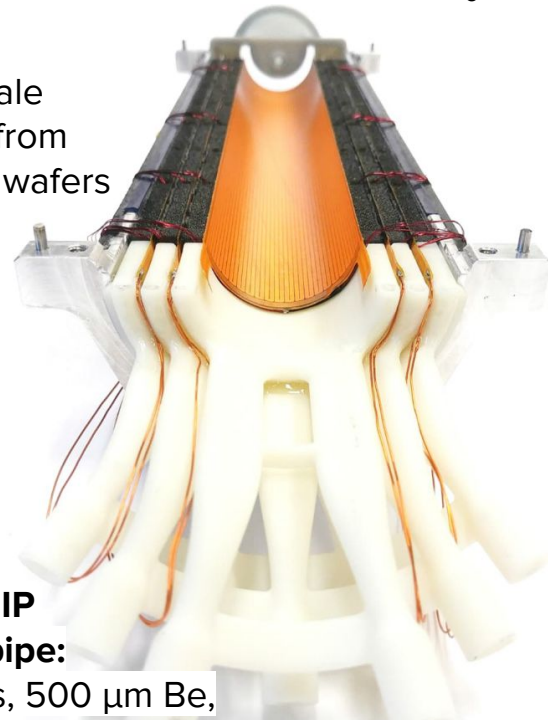
ITS2

24120
chips from
200 mm
wafers

22 mm from IP

Very low material budget! 0.05% X_0 per layer

Stitched,
wafer-scale
sensors from
300 mm wafers



18 mm from IP

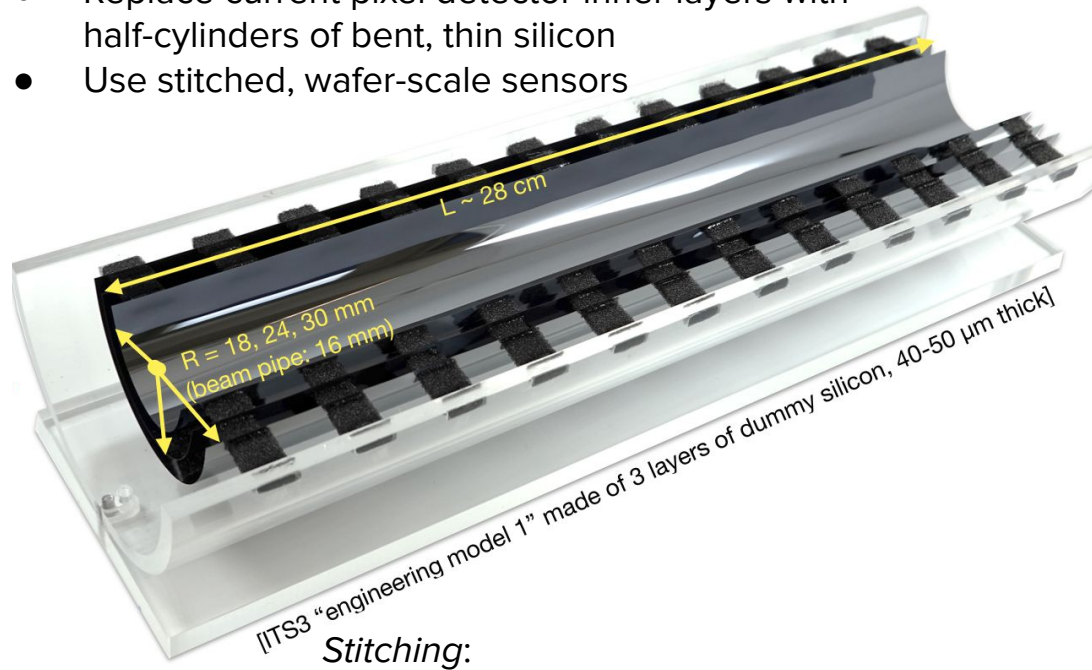
New beam pipe:

16 mm radius, 500 μm Be,
0.14% X_0

ITS3

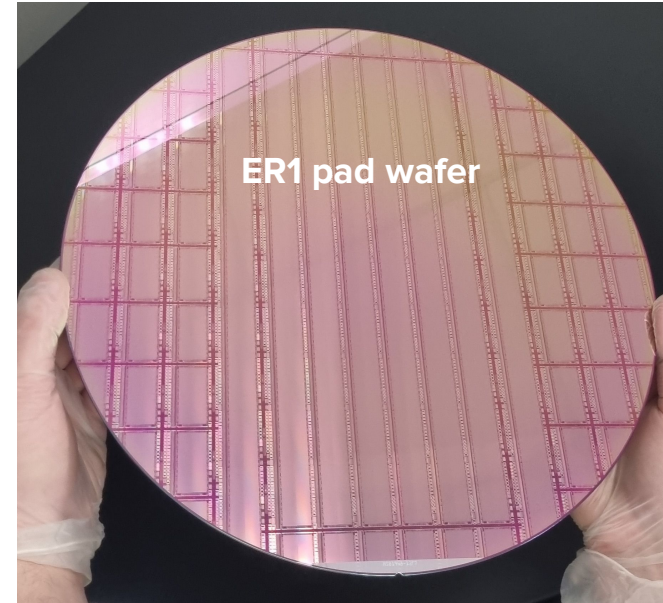
ITS3: three new, ultralight, truly cylindrical layers

- Replace current pixel detector inner layers with half-cylinders of bent, thin silicon
- Use stitched, wafer-scale sensors



Stitching:

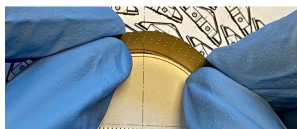
- put design blocks together during processing of silicon
- Can make chip larger than the field of view of the lithographic equipment



Pad wafer in engineering run 1 (ER1) using stitching: 25.9 cm long sensor

ALICE ITS3 for Run 4

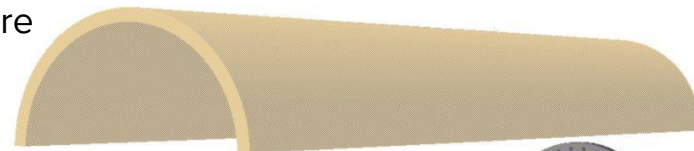
Each half layer is one single pixel sensor!



Stitching and bending

- Material: $X/X_0 \approx 0.05\%$
ITS2 (now): 0.36% (inner), 1.1% (outer)
- 6 half-layer sensors with 3-5 wafer-scale monolithic active pixel sensors (MAPS)
- Half layer sensor of size of $280 \times 53.3 \text{ mm}^2$ in layer 0
- Thinned to $40\text{-}50 \text{ }\mu\text{m}$
- Mechanically held in place by carbon foam

Cylindrical support structure

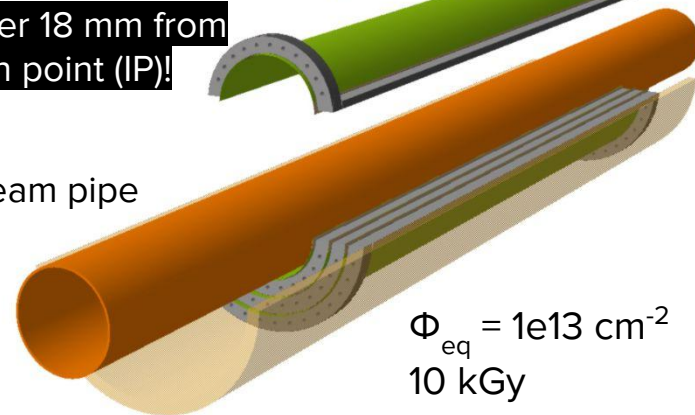


Half-layer sensor



Innermost layer 18 mm from the interaction point (IP)!

Beam pipe

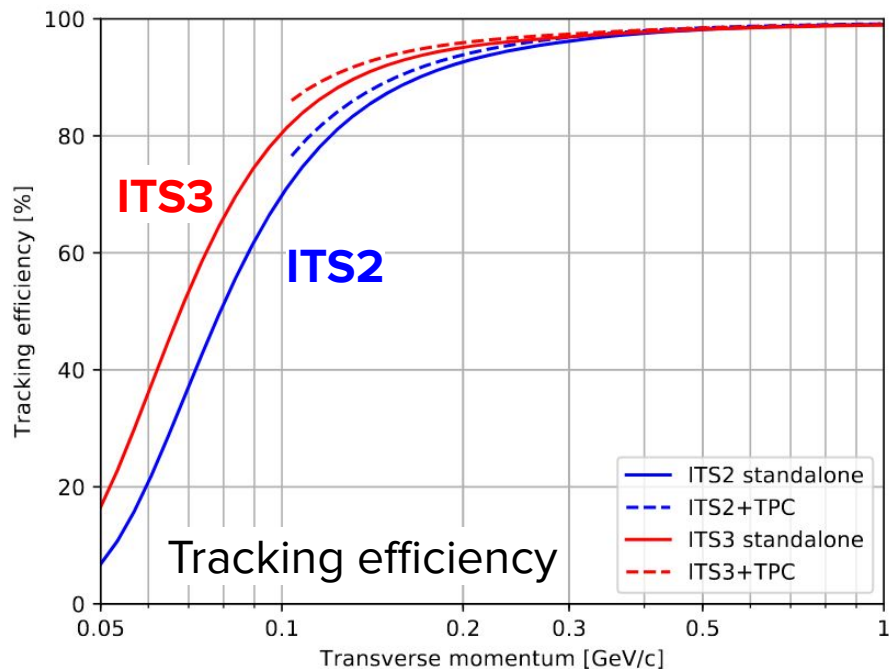


$$\Phi_{\text{eq}} = 1\text{e}13 \text{ cm}^{-2}$$

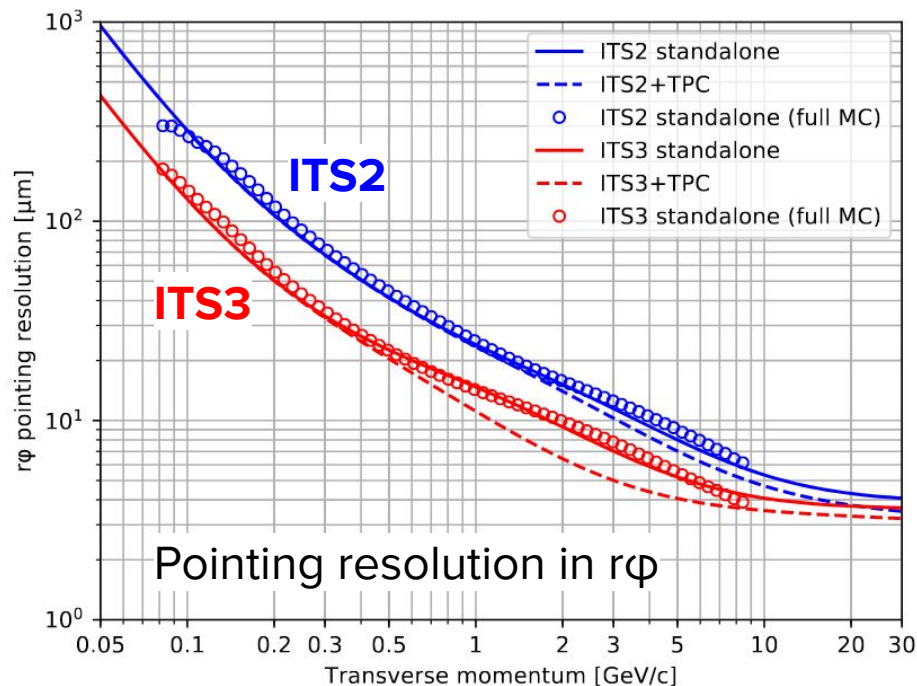
$$10 \text{ kGy}$$

Improved measurements with more precise vertexing and tracking

ITS3: more precise vertexing and tracking



Large improvement especially at low p_T

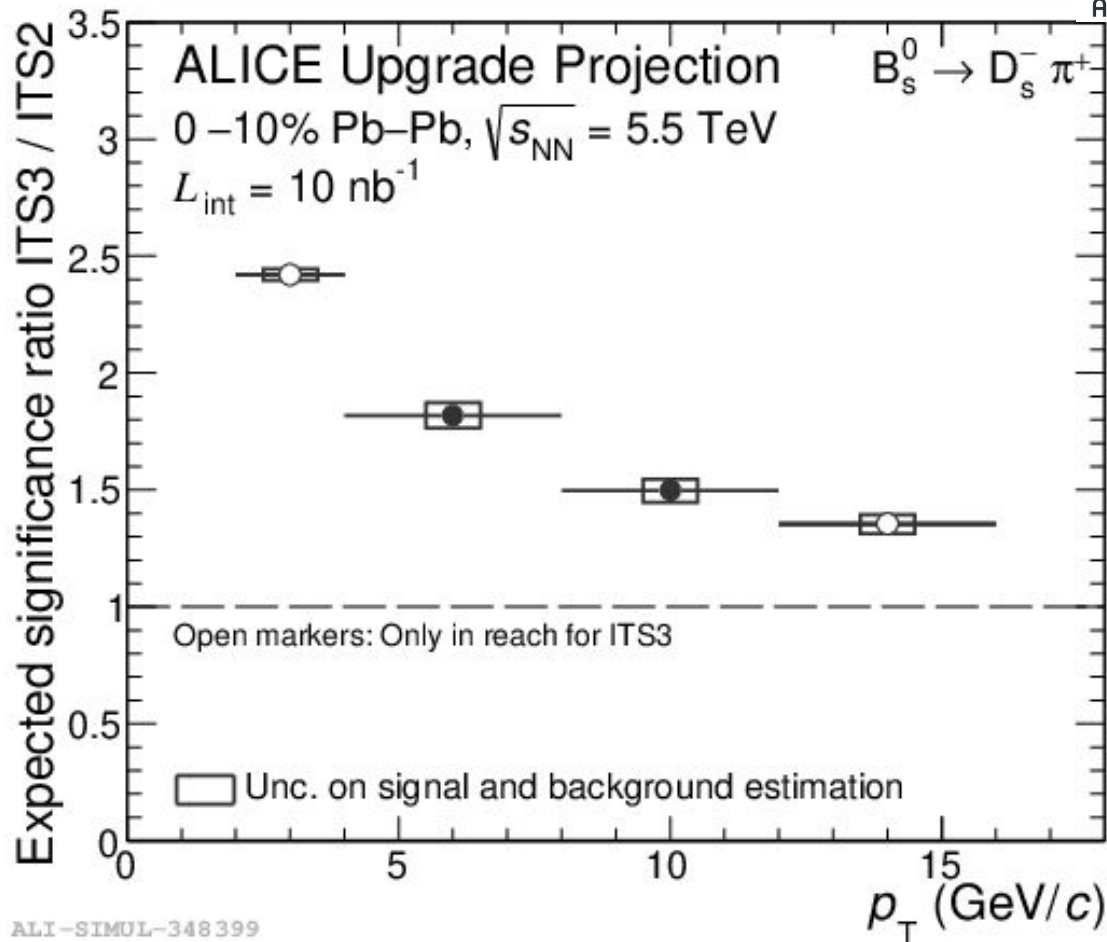


Factor 2 improvement over all momenta

Strange beauty particles

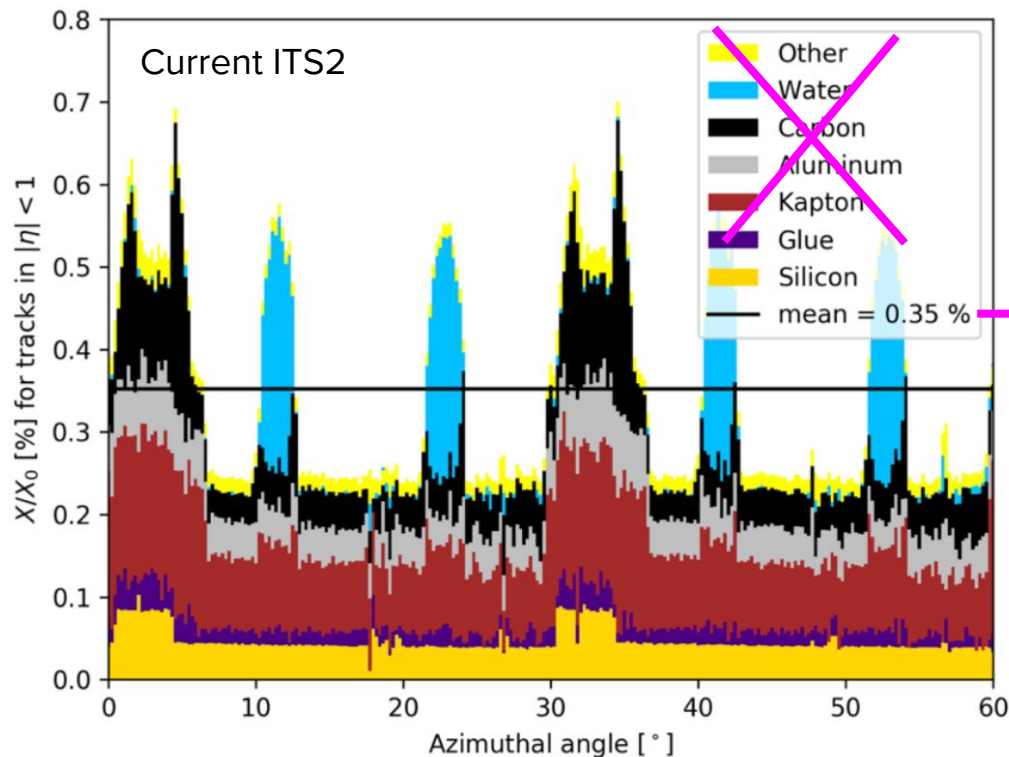
- For studies of hadronisation in heavy ion collisions
- The Compact Muon Solenoid (CMS) Experiment made first measurement $B_s^0 / B_{\text{not } S}$ in Pb Pb collisions vs pp collisions – with large uncertainties
- ALICE [also measured this](#)
- Both see an enhancement, but no significant observation
- Large improvement with ITS3
- ITS3 can extend measurement to lower p_T

This all thanks to a close proximity to IP and a very low material budget!



Where did all the material go?

Remove “unnecessary” material from ITS2



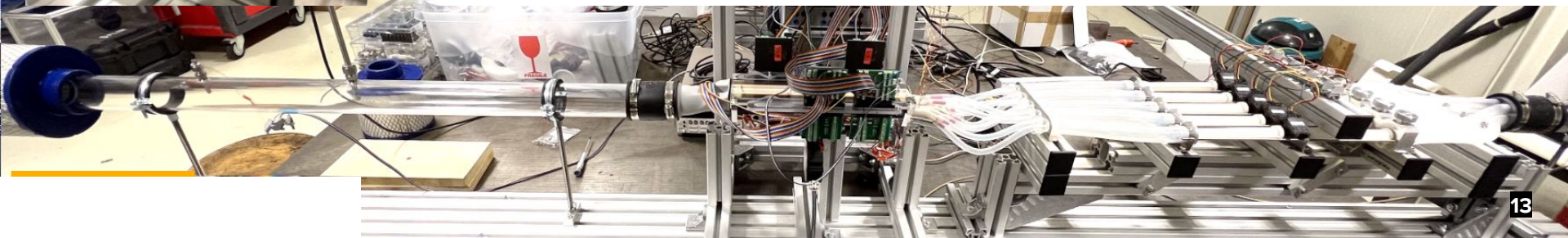
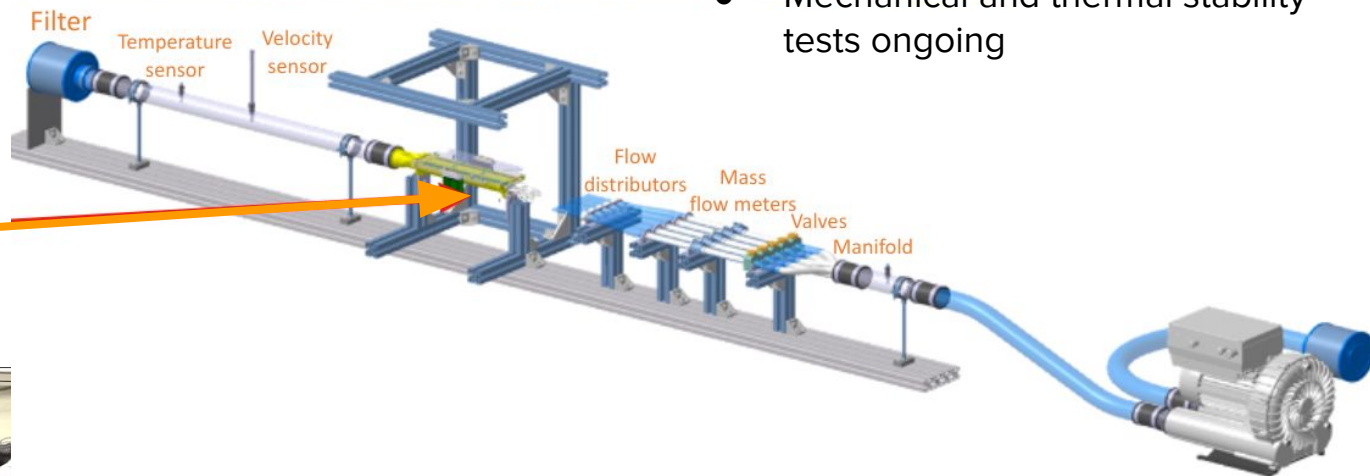
- Circuit board (kapton, aluminum): not required if power and data are integrated into the silicon

Mean 0.05% per layer

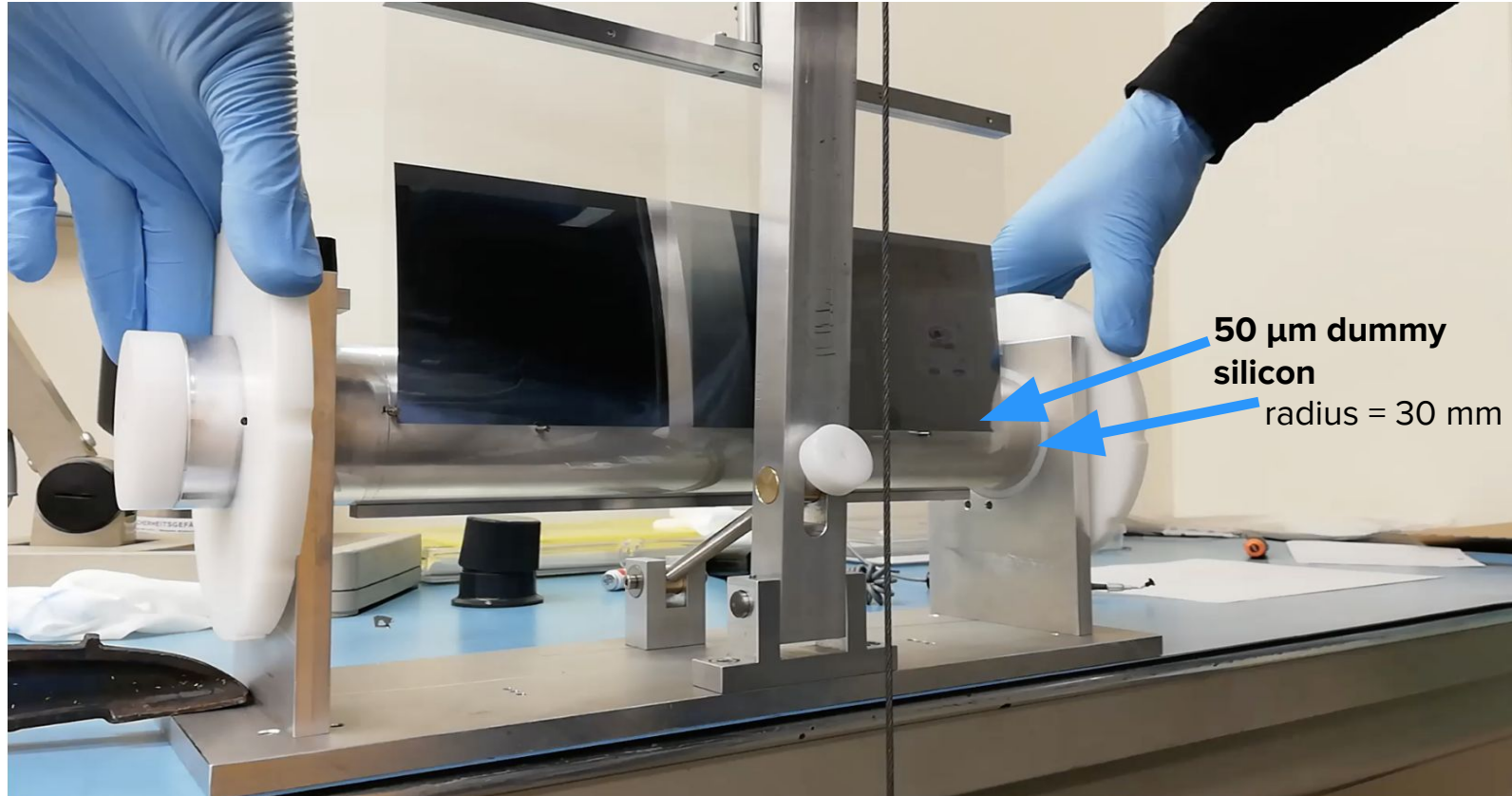
- Water cooling → replace with air cooling. Requires $< 20 \text{ mW/cm}^2$
- Less mechanical support (carbon, glue) needed for large, bent sensors!

Testing the air cooling

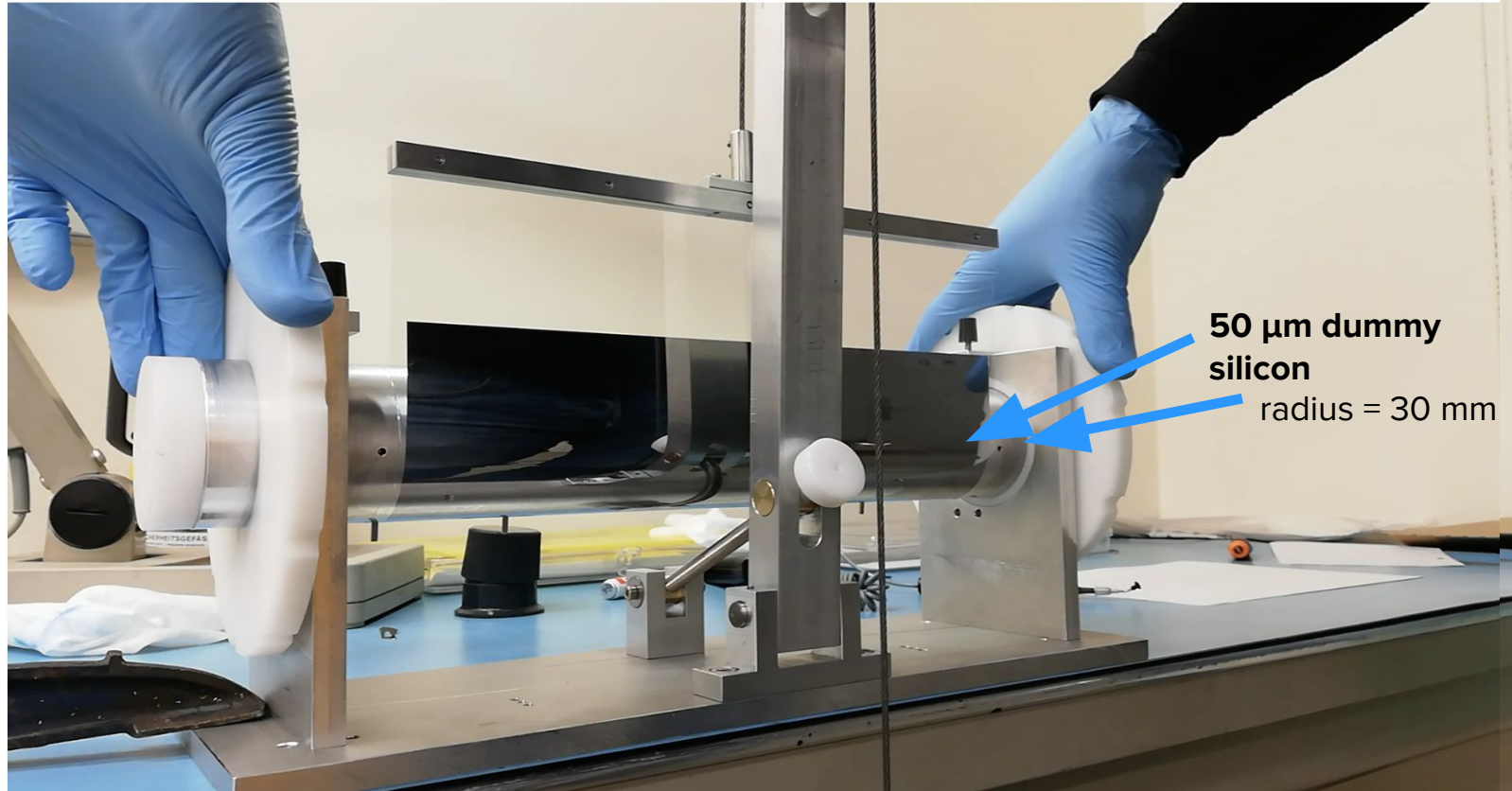
- Setup commissioned
- Mechanical and thermal stability tests ongoing



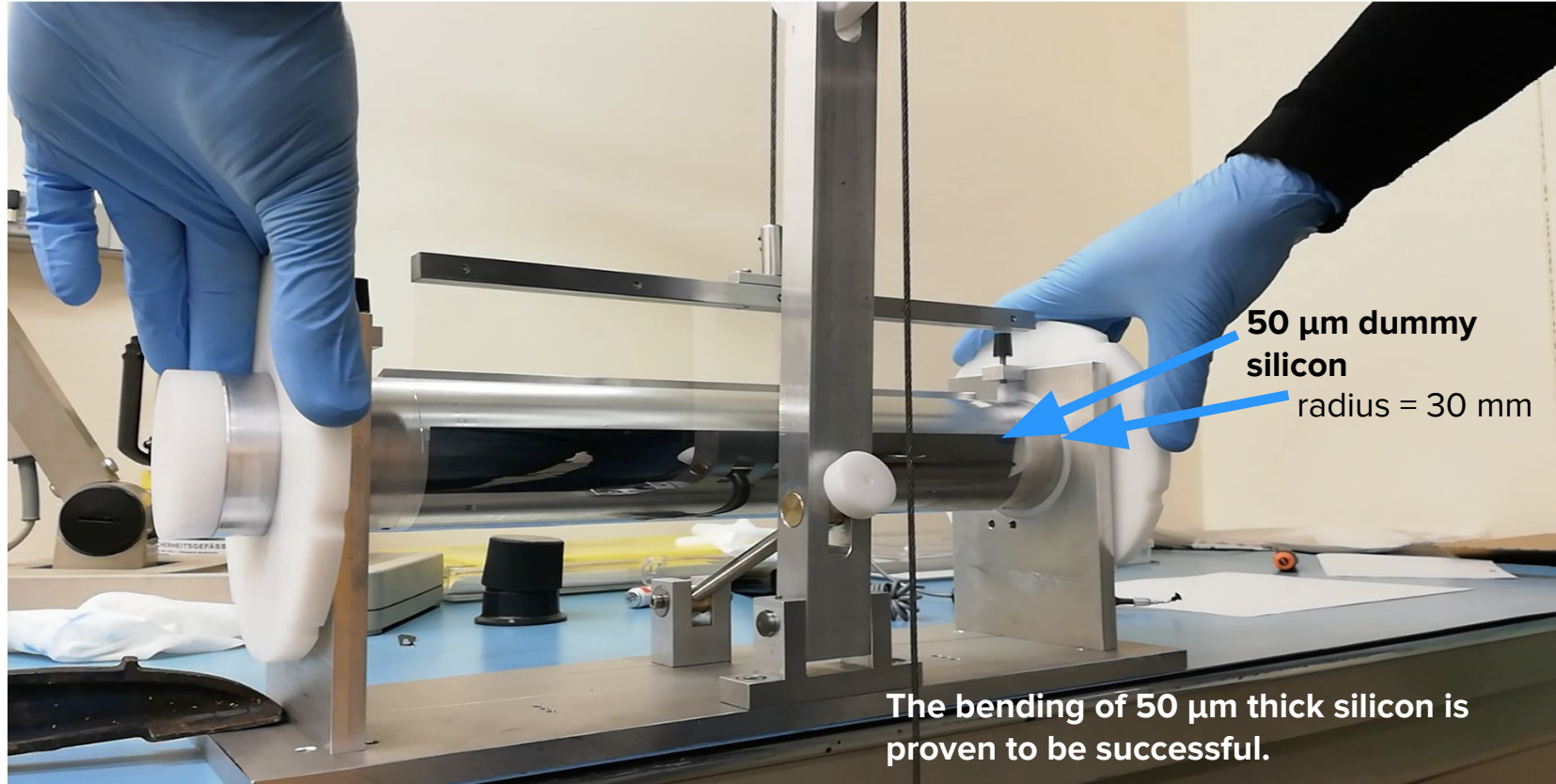
Silicon flexibility and bending



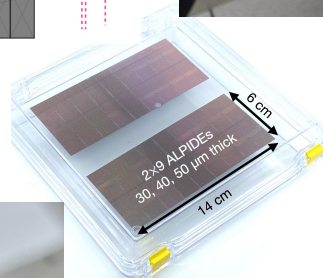
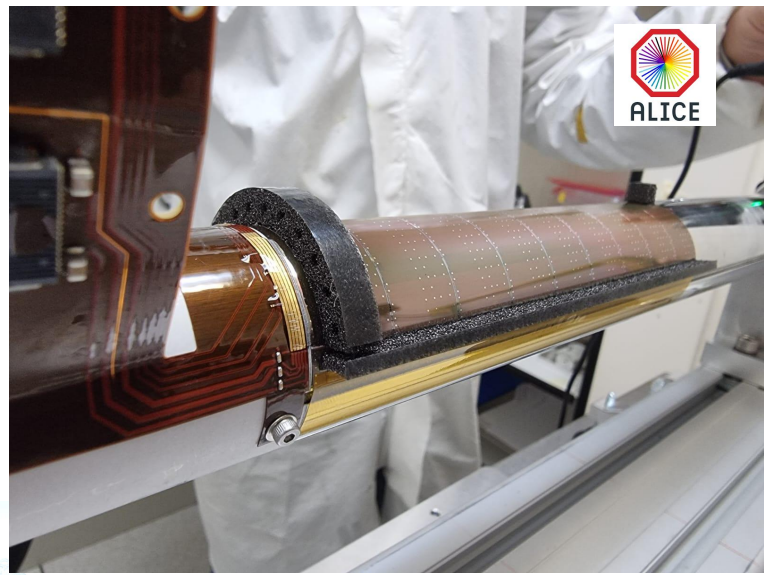
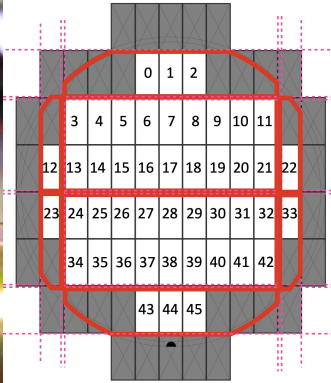
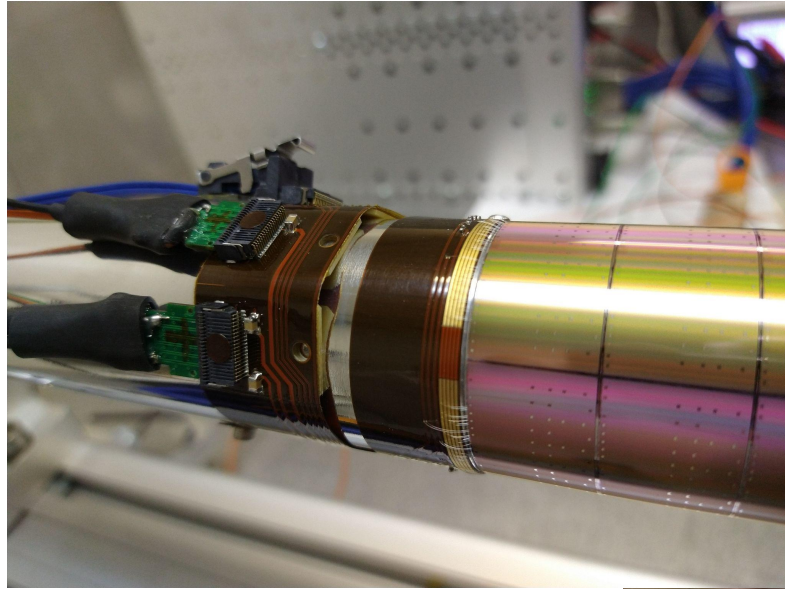
Silicon flexibility and bending



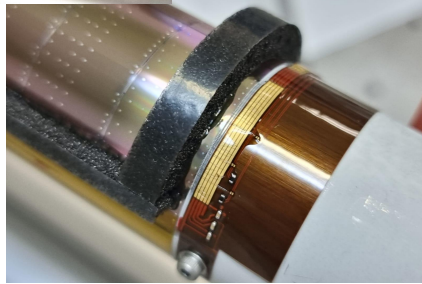
Silicon flexibility and bending



First bending with *superALPIDEs*

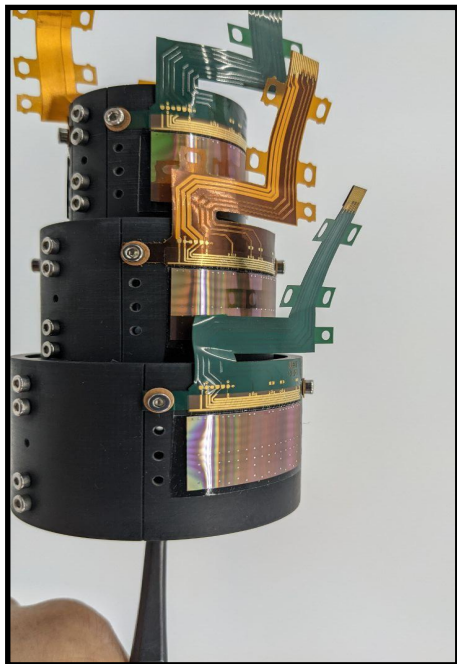


- ALPIDE: ALICE Pixel DEtector used in ITS2
- 40 μm thick sensors
- Bent to a radius of 18 mm

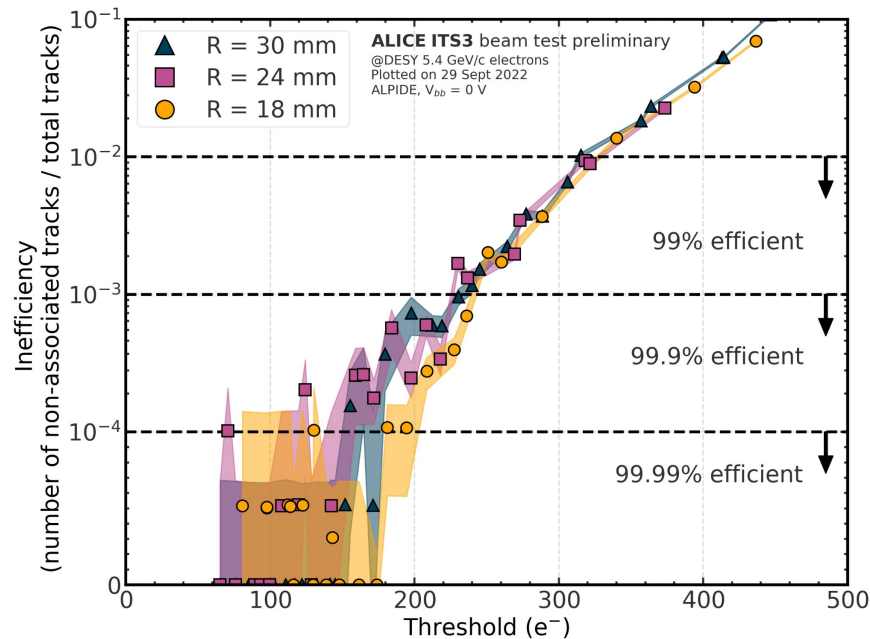


Beam test studies with bent sensors

- Bending silicon wafers and functional ALPIDEs is now routine
- Full mock-up of the final ITS3: “ μ ITS3” bent to ITS3 radii tested
- Spatial resolution uniform among different radii
- Efficiency and resolution consistent with flat ALPIDEs



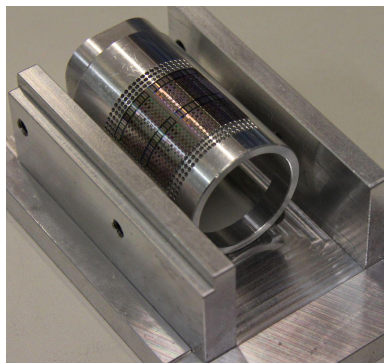
More results in [doi:10.1016/j.nima.2021.166280](https://doi.org/10.1016/j.nima.2021.166280)



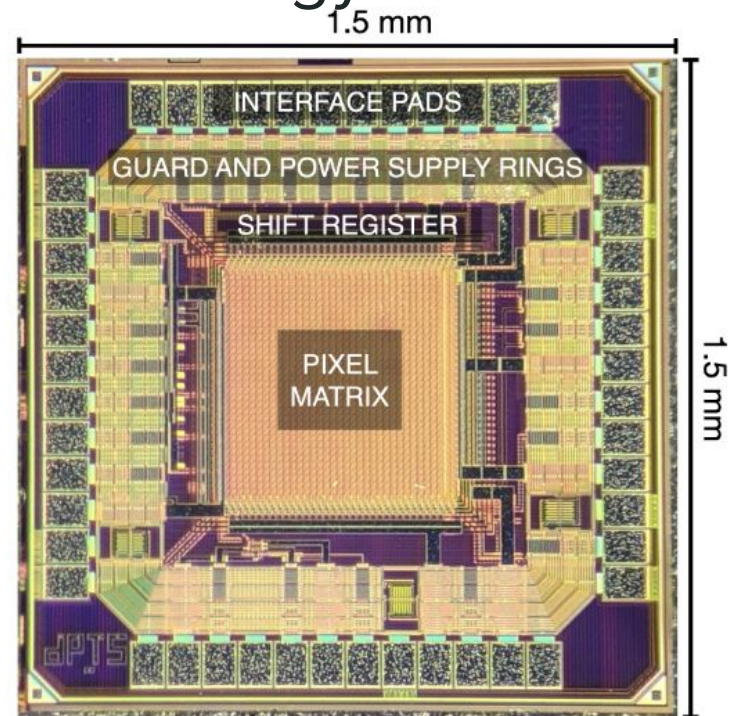
Sensor R&D

Characterization of new 65 nm technology for ITS3

- Several submissions, prototype of final wafer-scale chip expected 2024
- Now investigating many different small prototypes from a multi-layer reticle to qualify 65 nm technology
- One such prototype is a digital pixel test structure that acts as a technology demonstrator
- Results published: [doi:10.48550/arXiv.2212.08621](https://doi.org/10.48550/arXiv.2212.08621)



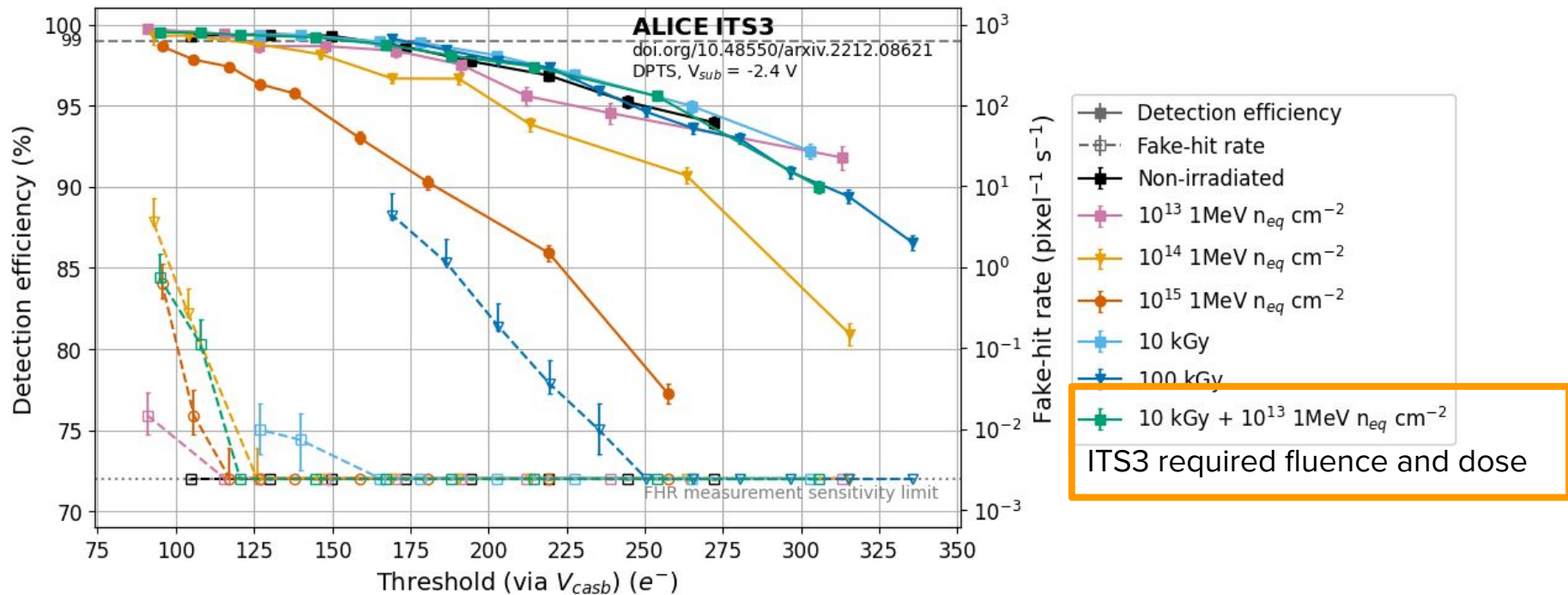
First chips bent to 18 mm radius and successfully tested with Fe-55 source



doi:10.48550/arXiv.2212.08621

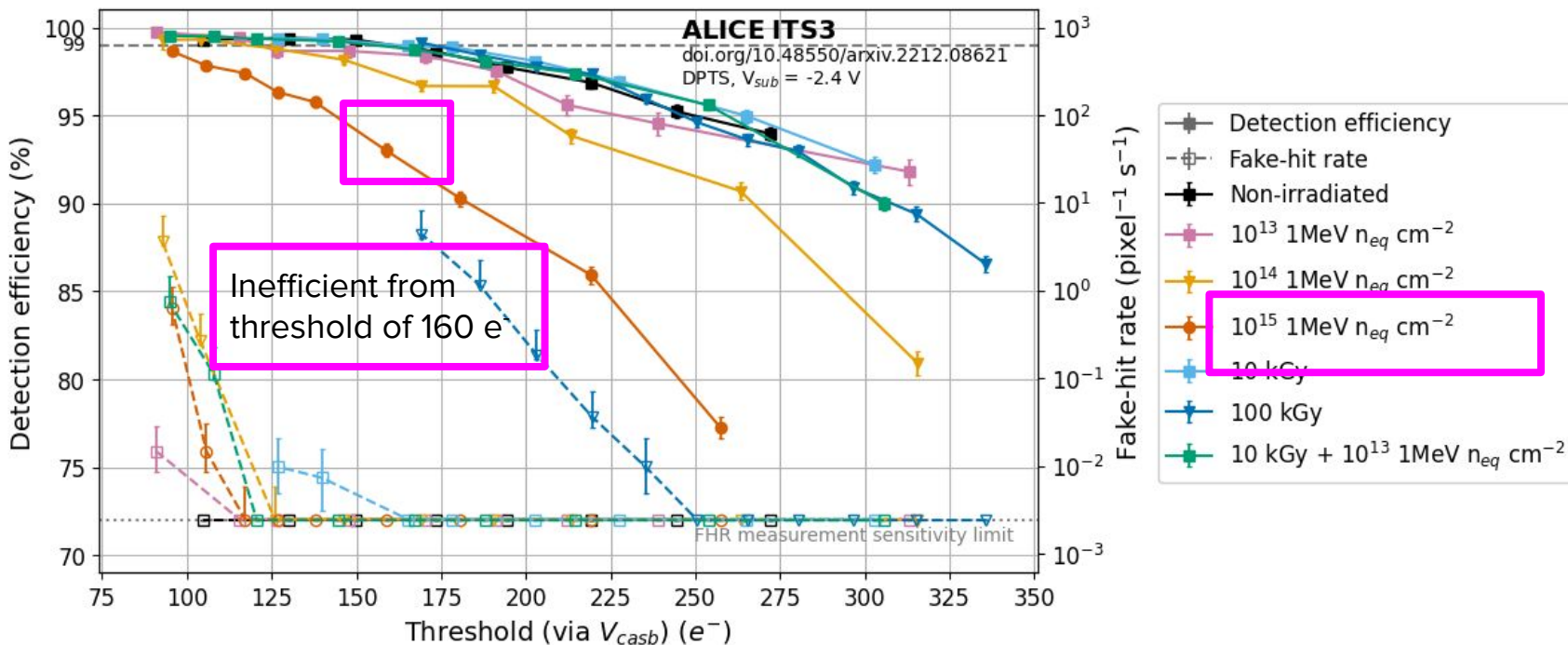
- 32 by 32 pixels with asynchronous digital readout
- $15 \times 15 \mu\text{m}^2$ pixels whose position is time encoded in the readout

Digital pixel test structure efficient after irradiation



- Operated at room temperature!
- 100% efficient after ITS3 fluence
- Sensor still operable at 99% efficiency at 20°C after $\Phi_{eq} = 10^{15} / cm^2$

Digital pixel test structure efficient after irradiation



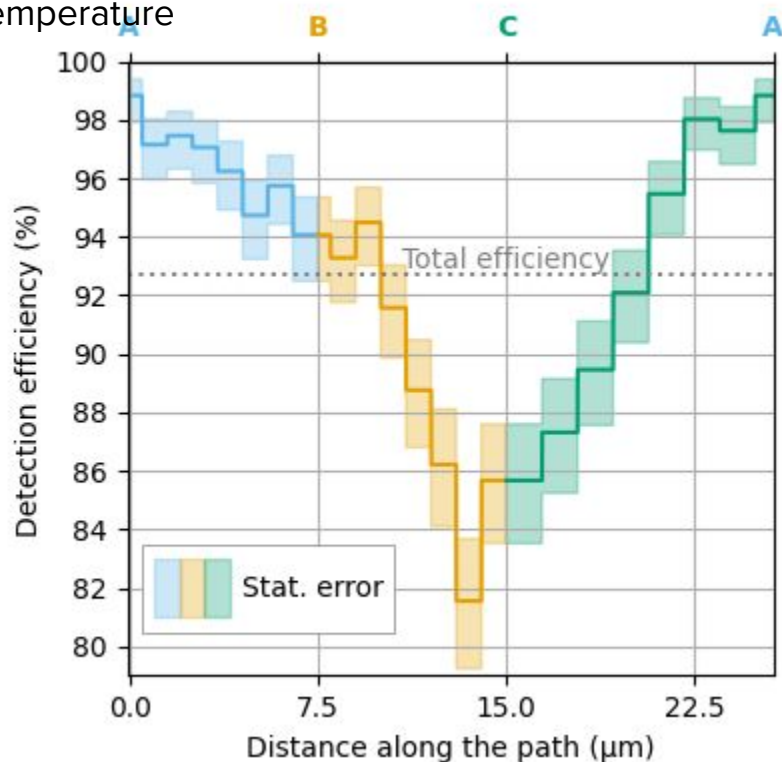
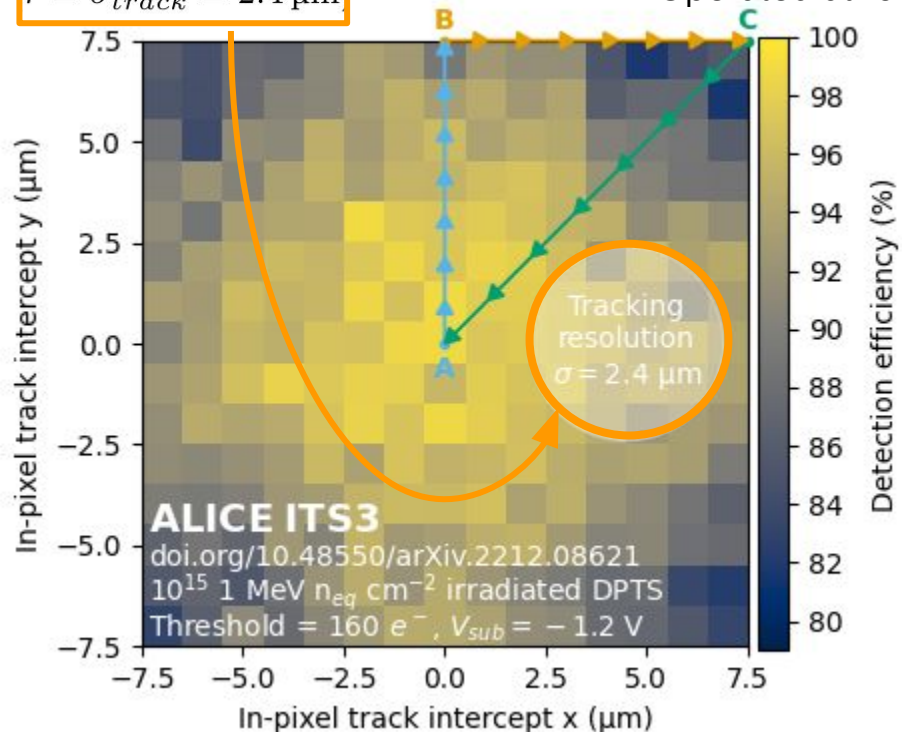
- Operated at room temperature!
- 100% efficient after ITS3 fluence
- Sensor still operable at 99% efficiency at 20°C after $\Phi_{eq} = 10^{15} / \text{cm}^2$

In-pixel detection efficiency after $\Phi_{eq} = 10^{15} / \text{cm}^2$

Track spatial resolution:

$$r = \sigma_{track} = 2.4 \mu\text{m}$$

- Threshold $160 e^-$
- Operated at room temperature

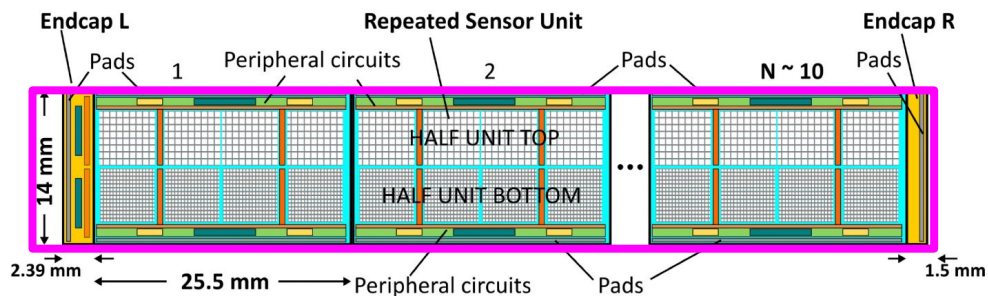
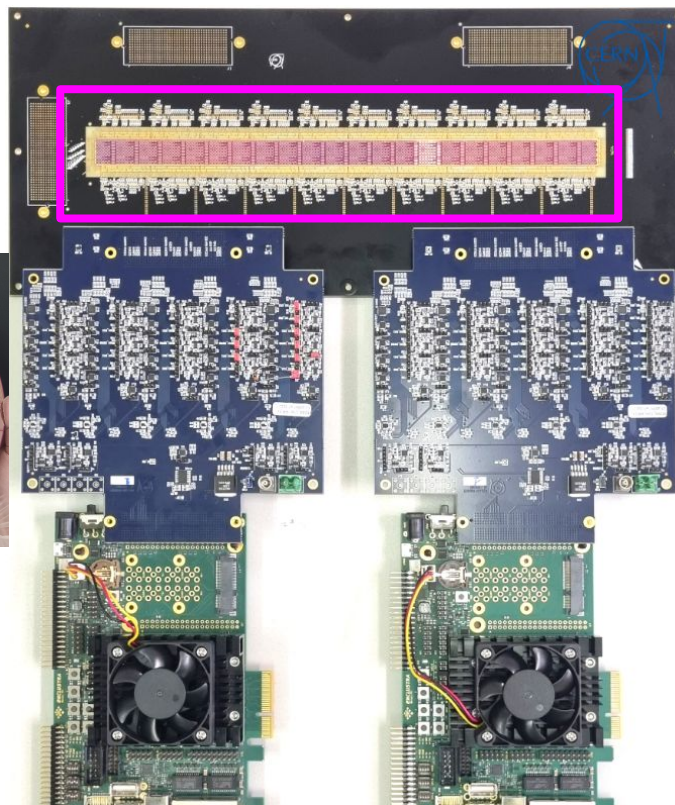
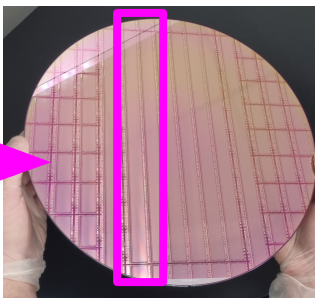


doi:10.48550/arXiv.2212.08621

Efficiency loss as expected: occurs in corners far from collection electrode. No charge sharing.

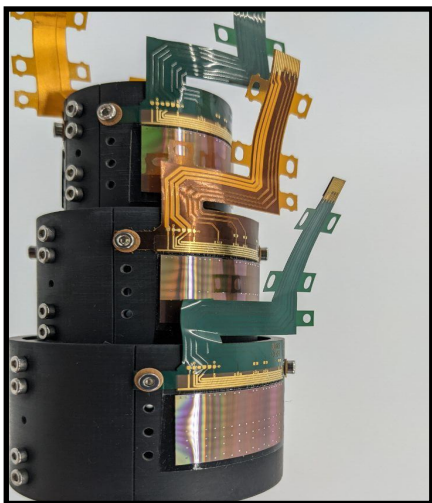
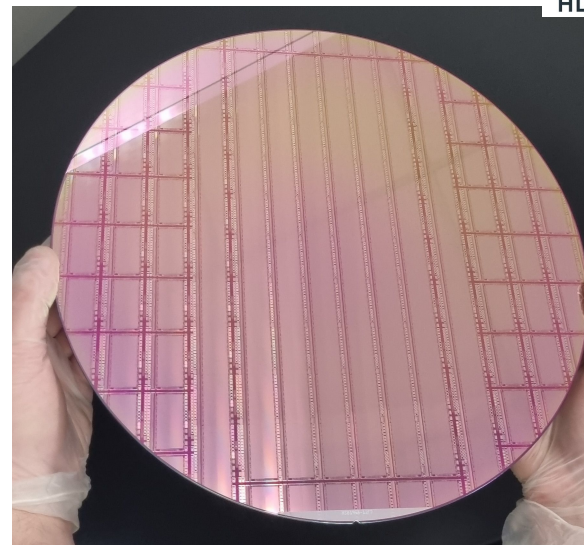
Stitched sensor prototypes

- 2 different structures, MOSS and MOST
- 14 x 259 mm², 6.72 MPixel structure
- Full structure will be 2.5 times as large
- Pixels of 22.5 x 22.5 μm² and 18 x 18 μm²
- To be tested for yield and uniformity
- Pad wafer at CERN
- First full wafers arriving soon



Summary and outlook

- Installation of new inner layers for ALICE inner tracking system 3 (ITS3) for LHC Run 4 in 2028
- Aim for truly cylindrical wafer-scale monolithic active pixel sensors
- Silicon flexibility and bending proved with routine bending tests
- Full mockup of ITS3 efficient when bent to ITS3 target radii

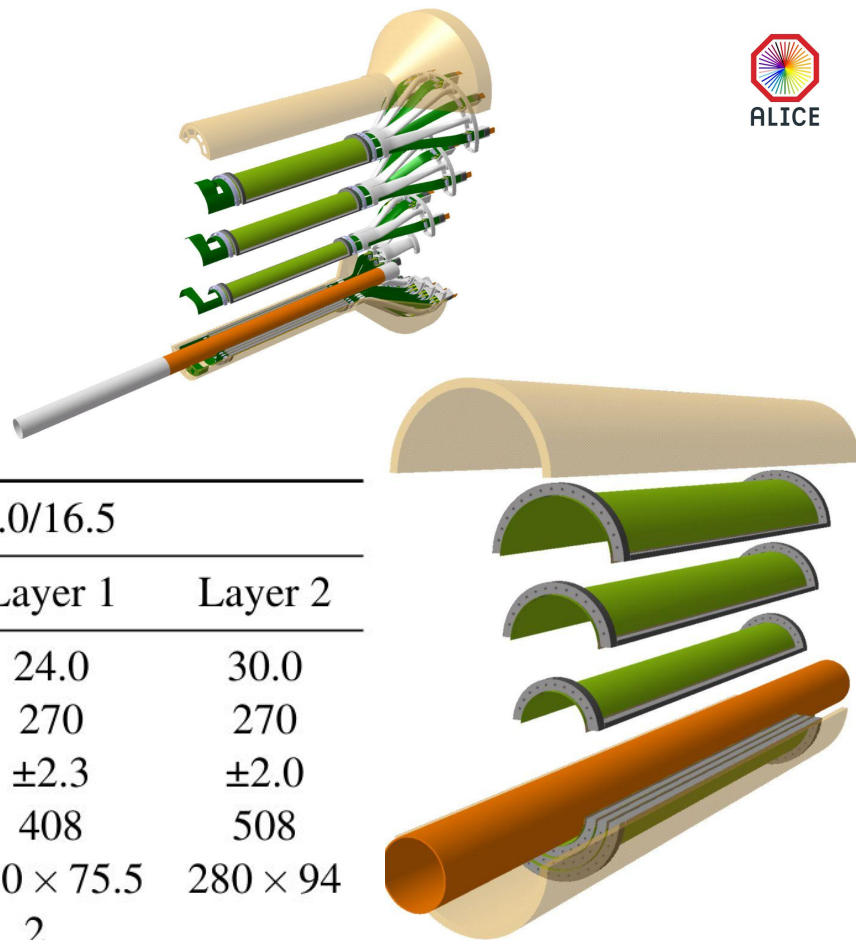


- Sensor prototypes reach 100% detection efficiency at room temperature at ALICE ITS3 fluence requirement of $\Phi_{eq} = 10^{13} / \text{cm}^2$
- Sensor still operable at room temperature after $\Phi_{eq} = 10^{15} / \text{cm}^2$
- First stitched sensors on their way and to be tested soon
- ITS3 R&D will pave the way to thin, low-power sensors that could be used in ALICE 3 (see talk by Alessandro Grelli in this session)

ITS3 is a successful R&D project that will enable a wealth of new precision measurements.

Additional material

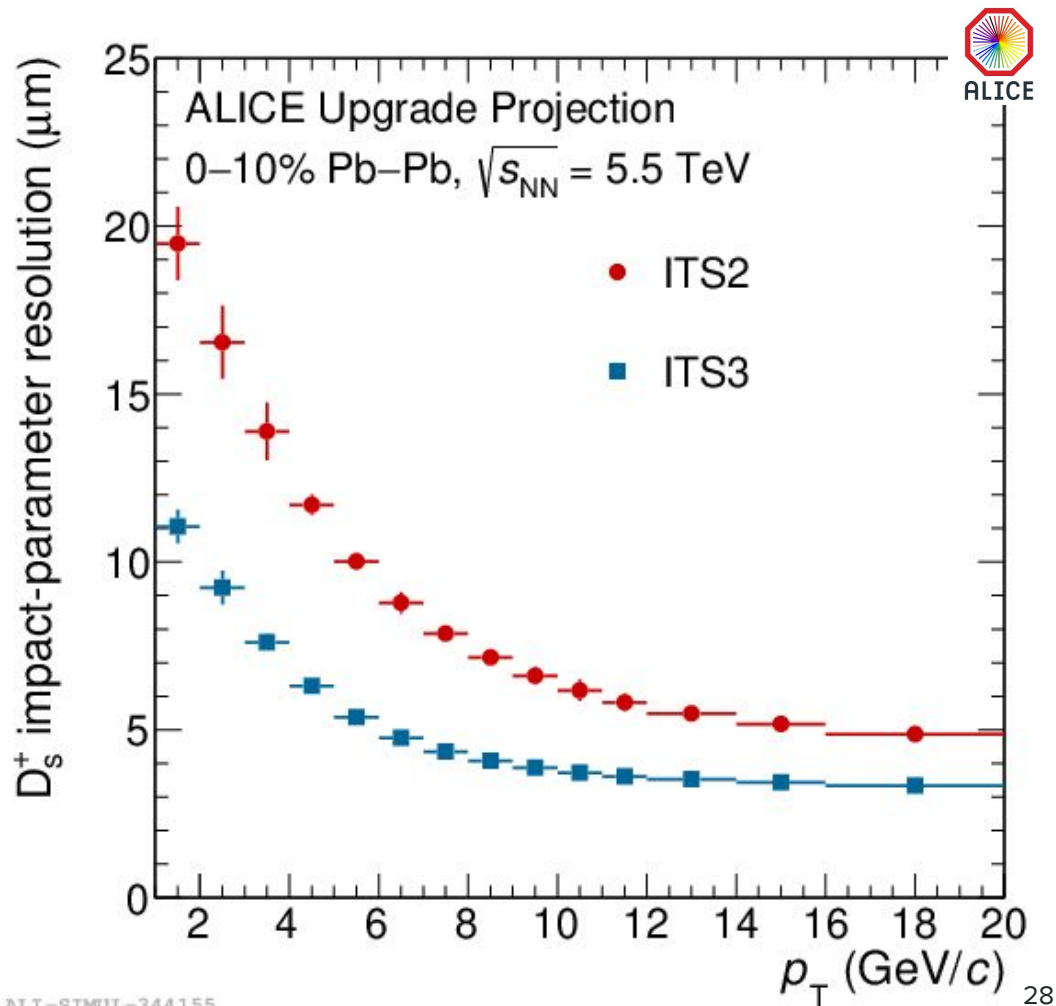
ITS3 geometry



Beampipe inner/outer radius (mm)	16.0/16.5		
IB Layer parameters	Layer 0	Layer 1	Layer 2
Radial position (mm)	18.0	24.0	30.0
Length (sensitive area) (mm)	270	270	270
Pseudo-rapidity coverage ^a	± 2.5	± 2.3	± 2.0
Active area (cm ²)	305	408	508
Pixel sensors dimensions (mm ²)	280 × 56.5	280 × 75.5	280 × 94
Number of pixel sensors / layer	2		
Pixel size (μm ²)	$O(15 \times 15)^b$		

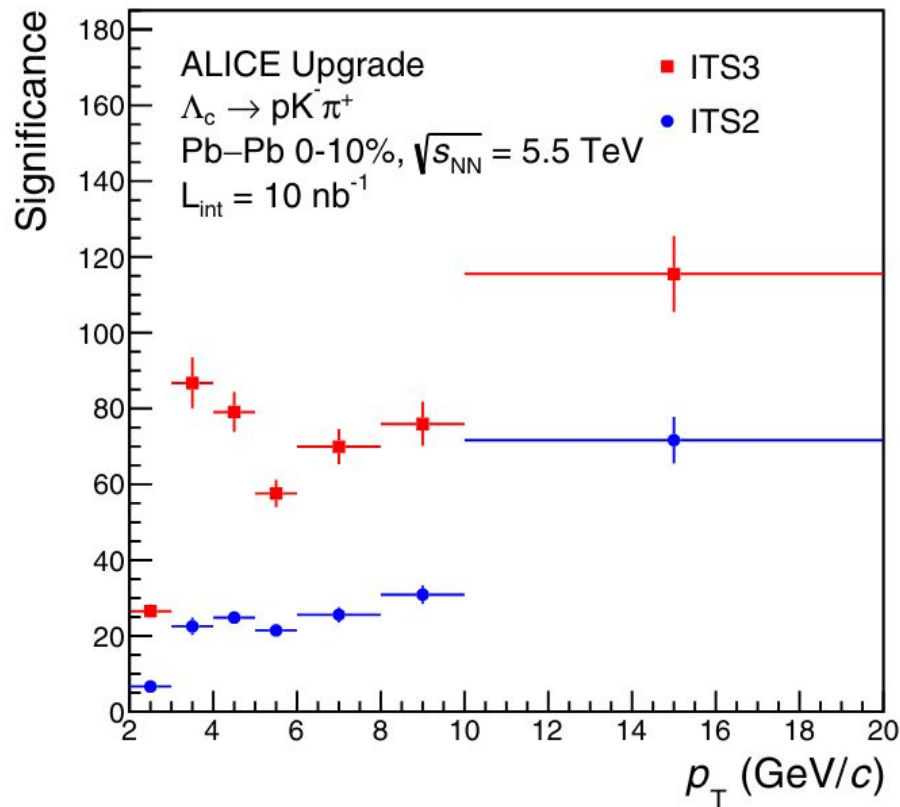
Non-prompt D mesons

- Highly sensitive to beauty-strange hadron production in quark gluon plasma
- $\text{Br}(B_s^0 \rightarrow D_s^+ + X) = (93 \pm 25)\%$
- Higher background rejection resulting from improved track spatial resolution



Better reconstruction of short-lived hadrons in ITS3

- Short lifetime:
 $c\tau(\Lambda_c^+) \sim 59 \mu\text{m}$
 twice smaller than D^0 meson
- Decay tracks displaced $O(10) \mu\text{m}$ from IP
- Significance of Λ_c in pion decay channel more than doubles in ITS3 for low momenta

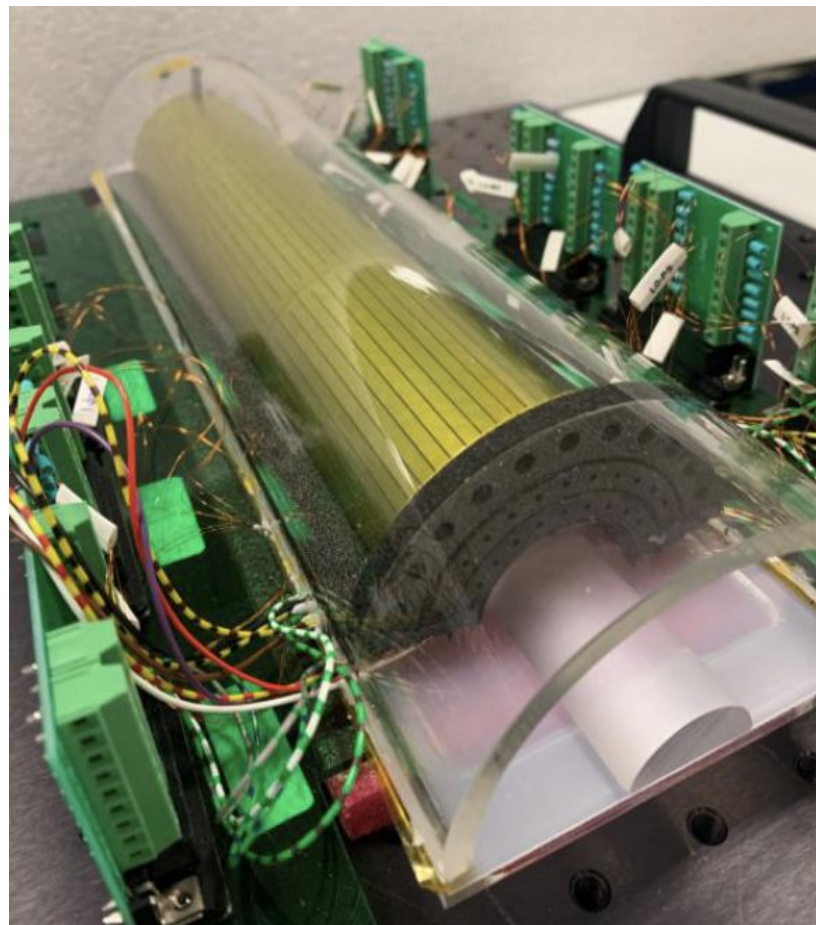
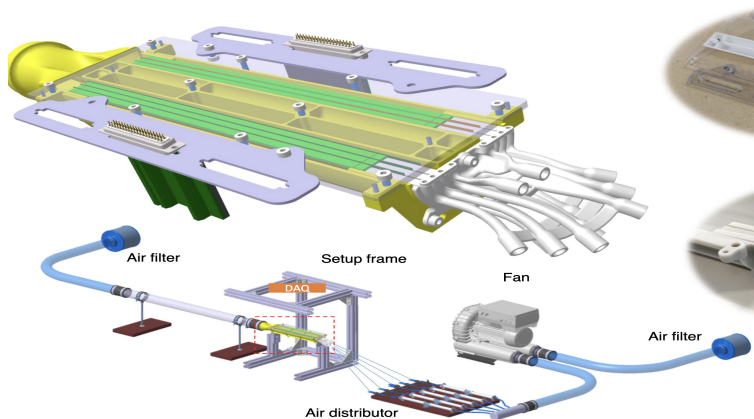


Current inner tracking system ITS2 inner three layers



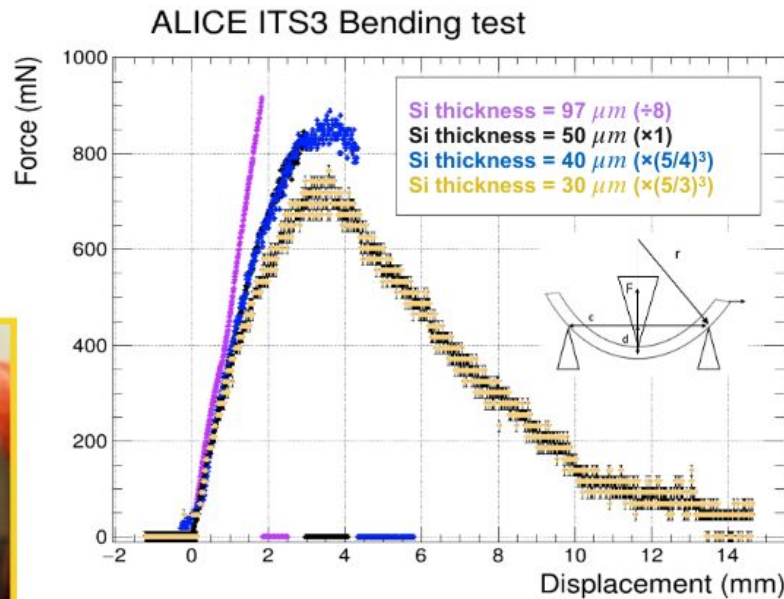
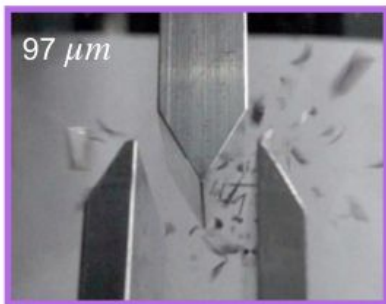
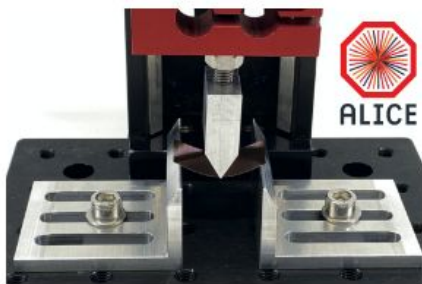
Air cooling

- Thermal and stability tests ongoing
- Development of models based on heating elements
- Placed in custom wind tunnel to study thermal and mechanical properties



Bending tests

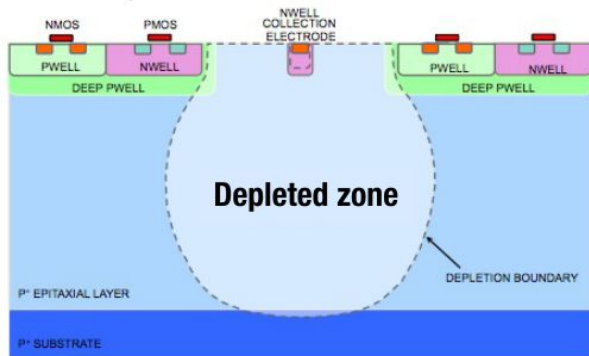
- Breaking point goes moves to smaller bending radii for thinner integrated sensors
- Bending force scales with the thickness to the third power



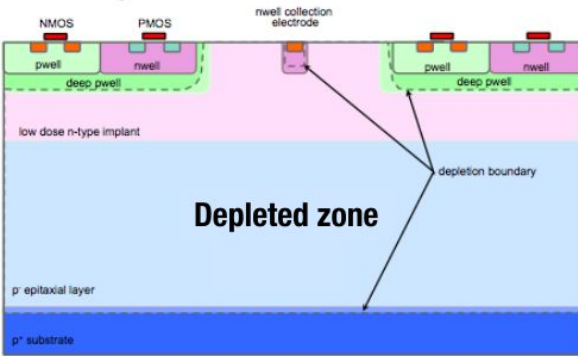
Different process modifications

- Motivated by better charge collection
- Higher speed may serve for monolithic sensors with timing functionality that could be applied in ALICE3

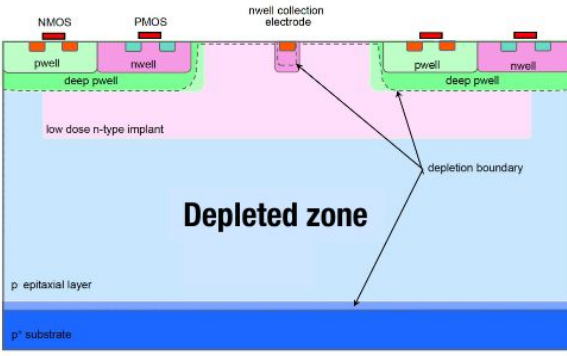
Standard process



Modified process



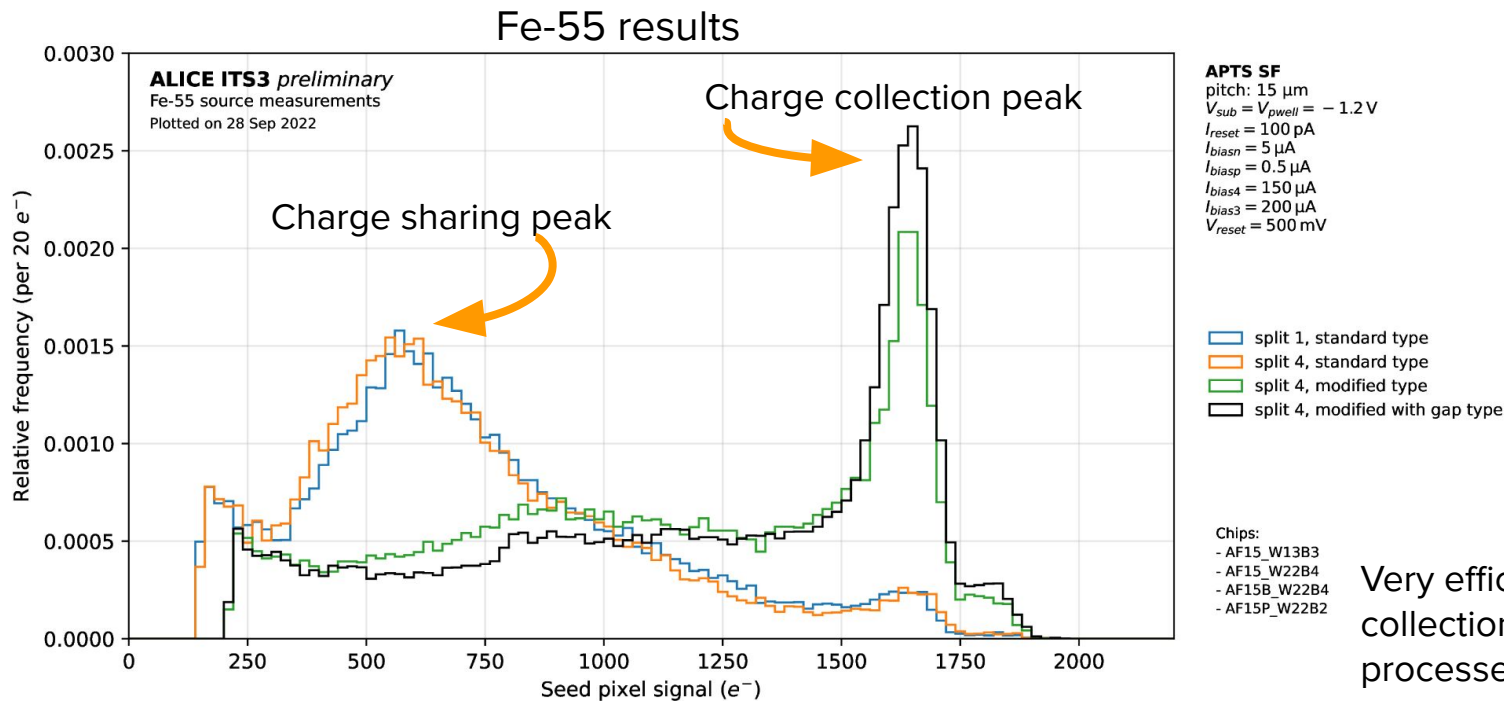
Modified process with gap



Charge sharing

Charge Collection efficiency and speed

Analog pixel test structure results



Very efficient charge collection for modified processes